

# Search Notes



Application/Control No.

10/529,732

Applicant(s)/Patent under Reexamination

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Examiner

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Art Unit

2851

## SEARCHED

Class	Subclass	Date	Examiner
353	84,20,30,3 1,34,88,89 .97	2/26/2007	AK
UPDATE			
353	85		
349	5.7		
359	888		
	889	7/16/07	WCD

## INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
w/ search 7/16/07 WCD			

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
EAST search (USPGPUB,USOCR,USPAT EPO,JPO)	2/26/2007	AK
Attached	7/16/07	WCD